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CONFIRMATION NO. 9428

<b>SERIAL NUMBER</b> 10/678,139	<b>FILING OR 371(c) DATE</b> 10/06/2003 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2822	<b>ATTORNEY DOCKET NO.</b> 740756-2659
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 09/838,216 04/20/2001 PAT R,E38,266 which is a REI of 09/115,838 07/15/1998 PAT 6,071,766 which is a DIV of 08/536,977 09/29/1995 PAT 5,789,284

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 6-259117 09/29/1994

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 9	<b>TOTAL CLAIMS</b> 22	<b>INDEPENDENT CLAIMS</b> 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <u>Examiner's Signature</u> <u>Initials</u>				

## ADDRESS

22204

## TITLE

Method for fabricating semiconductor thin film

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